



Docket No.: 1592-0169PUS1  
(PATENT)

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Patent Application of:  
Takashi OZAKI et al.

Application No.: 10/549,938

Confirmation No.: 7521

Filed: January 3, 2007

Art Unit: 2891

For: PRODUCING METHOD OF  
SEMICONDUCTOR DEVICE AND  
SUBSTRATE PROCESSING APPARATUS

Examiner: C. Everhart

**AMENDMENT IN RESPONSE TO NON-FINAL OFFICE ACTION**

MS Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

**INTRODUCTORY COMMENTS**

In response to the Office Action dated April 23, 2008, the period for response having been extended two (2) months to September 23, 2008, please amend the above-identified U.S. patent application as follows:

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 14 of this paper.

09/24/2008 JADD01 00000048 022448 10549938  
01 FC:1201 1050.00 DA  
02 FC:1202 150.00 DA  
03 FC:1203 370.00 DA